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UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Grant W. McEwan et al GROUP ART UNIT: 2813
APPLN. NO.: 10/736,395 EXAMINER: Thanh T. Nguyen
FILED: December 15, 2003
TITLE: METHOD FOR PRODUCING CORROSION OF METAL SURFACES
DURING SEMICONDUCTOR PROCESSING

Certificate of Mailing

Date of deposit:

August 25, 2005

I hereby certify that this paper is being deposited with the United States Postal Service on the date indicated above, as first-class mail, with sufficient postage attached thereto, in an envelope addressed to the Commissioner for Patents, Alexandria, VA 22313.

Signature of Person Mailing Paper

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 13, 2005, and Examiner's comments with regard thereto, please enter the following amendments in the above-entitled application, without prejudice or disclaimer.

If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 503079.